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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/611,395	06/30/2003	Shriram Ramanathan	42P16666 1525		
	7590 04/17/200 KOLOFF TAYLOR &	EXAMINER			
12400 WILSHI	RE BOULEVARD		DOTY, HEATHER ANNE		
SEVENTH FLO LOS ANGELE	S, CA 90025-1030	ART UNIT	PAPER NUMBER		
	•		. 2813		
SHORTENED STATUTOR	Y PERIOD OF RESPONSE	MAIL DATE	DELIVERY MODE		
3 MO	NTHS	04/17/2007	PAPER		

Please find below and/or attached an Office communication concerning this application or proceeding.

If NO period for reply is specified above, the maximum statutory period will apply and will expire 6 MONTHS from the mailing date of this communication.

Office Action Summary Examiner			Application	Application No. Applicant(s)				
Heather A. Doby 2813			10/611,39	5	RAMANATHAN ET AL.			
The MALLING DATE of this communication appears on the cover sheet with the correspondence address - Period for Repty A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) OR THIRTY (30) DAYS, WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. Extensions of mem myle variable under the provision of 37 CRT 1:30(i). In or event, however, may a reply be timely filed If NO period for reply is appelled above, the macrimum abstratory period will apply and we legins \$1X, (0) MONTHS from the mailing date of this communication. Failute to receive day within the set or extended period for reply will, by sature, case the application for Sort 12 A1, 17-49(s). This action is FINAL. 2b) This action is non-final. 3) □ Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213. Disposition of Claims 4) □ Claim(s) 1-22 (s/are pending in the application. 4a) ○ Claim(s) 1-22 (s/are allowed. 5) □ Claim(s) 1-23 (s/are allowed. 6) □ Claim(s) 5-1-13-20 and 22-26 (s/are rejected. 7) □ Claim(s) 5-1-13-20 and 22-26 (s/are rejected. 7) □ Claim(s) 5-1-13-20 and 22-26 (s/are rejected. 7) □ Claim(s) 5-1-21 (s/are objected to by the Examiner. Application Papers 9) □ The drawing(s) filed on 30 June 0203 (s/are: a) □ accepted or b) □ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to See 37 CFR 1.81(d). 11) □ The drawing(s) filed on 30 June 0203 (s/are: a) □ accepted or b) □ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to See 37 CFR 1.121(d). 11) □ The drawing(s) filed on 30 June 0203 (s/are: a) □		Office Action Summary	Examiner		Art Unit			
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WHICHEVER IS LONGER, FROM THE MAILING DATE OF THIS COMMUNICATION. Extensions of time may be waited used the provisions of 3 CFR 1.13(6). In a reveal, however, may a reply be timely filed after 53k (8) MONTHS from the mailing date of this communication. Failure previously within the set or bearing date of this communication. Failure previously within the set or bearinded period for replywed. By statisse, such that page 1.2 (1) the Cliffic later than these months after the mailing date of this communication. Failure previously within the set or bearinded period for replywed. By statisse, such that page 1.2 (1) the Cliffic later than these months after the mailing date of this communication, even if timely filed, may reduce any search of the communication of the provious of the communication of th			n appears on the	cover sheet with the c	orrespondence ad	idress		
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DETAILED ACTION

This action is in response to the remarks filed 10/10/2006. Claims 1-27 remain pending.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless – (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-5 and 13-20 are rejected under 35 U.S.C. 102(e) as being anticipated by Tong et al. (U.S. 2004/0157407).

Regarding claim 1, Tong et al. teaches a method comprising:

- depositing a layer of metal on each of a number of conductors disposed on a first wafer (paragraphs 0048, 0075-0076);
- aligning the first wafer with a second wafer, the second wafer having a number of conductors disposed on a surface thereof (Fig. 2b);
- physically contacting the metal layer on each of the conductors of the first wafer with a mating one of the conductors on the second wafer (Fig. 2b);
 and
- forming a bond between the metal layer on each of the conductors of the first wafer and the mating one conductor of the second wafer (paragraph 0051; Fig. 2c), wherein all regions of the first and second wafer surfaces

surrounding the mating conductors remain unbonded (Fig. 2b shows all regions on the left and right sides of the mating conductors unbonded; contacting the mating conductors with each other constitutes forming a bond between the metal layers, and claim 1 does not specify a particular manner of bonding).

Regarding claim 2, Tong et al. teaches the method of claim 1, and further teaches, prior to depositing the metal layer on each of the conductors of the first wafer, removing dielectric material from the surface of the first wafer (paragraph 0063).

Regarding claim 3, Tong et al. teaches the method of claim 1, and further teaches, prior to depositing the metal layer on each of the conductors of the first wafer, removing native oxide from the conductors (paragraph 0075).

Regarding claims 4 and 5, Tong et al. teaches the method of claim 1, and further teaches that the conductors of the first wafer comprise copper and the metal comprises gold, platinum, or palladium (paragraphs 0075-0077).

Regarding claim 13, Tong et al. teaches a method comprising:

- depositing a layer of a first metal on each of a number of conductors disposed on a surface of a first wafer (paragraphs 0048, 0075-0076);
- depositing a layer of a second metal on each of a number of conductors disposed on a surface of a second wafer (paragraphs 0048, 0075-0076);
- aligning the first wafer with the second wafer (Fig. 2b);

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 physically contacting the metal layer on each of the conductors of the first wafer with the metal layer on a mating one of the conductors of the second wafer (Fig. 2b); and

• forming a bond between the metal layer on each of the conductors of the first wafer and the metal layer on the mating one conductor of the second wafer (paragraph 0051; Fig. 2c), wherein all regions of the first and second wafer surfaces surrounding the mating conductors remain unbonded (Fig. 2b shows all regions on the left and right sides of the mating conductors unbonded; contacting the mating conductors with each other constitutes forming a bond between the metal layers (paragraph 0060), and claim 1 does not specify a particular manner of bonding).

Regarding claim 14, Tong et al. teaches the method of claim 13, and further teaches, prior to depositing the metal layer on each of the conductors of the first wafer, removing dielectric material from the surface of the first wafer (paragraph 0063).

Regarding claim 15, Tong et al. teaches the method of claim 13, and further teaches, prior to depositing the metal layer on each of the conductors of the first wafer, removing native oxide from the conductors (paragraph 0075).

Regarding claims 16-18 and 20, Tong et al. teaches the method of claim 13, and further teaches that the conductors of each of the first and second wafers comprise the same metal, wherein that metal is copper, and wherein each of the first and second metals comprises gold, platinum, or palladium (paragraphs 0047-0050 discloses giving

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both wafers the same pre-bonding treatment; paragraph 0075 discloses copper, gold, and platinum; paragraph 77 discloses palladium).

Regarding claim 19, Tong et al. teaches the method of claim 13, and further teaches that the first metal and the second metal are different (paragraph 0018 discloses that an advantage to the invention is allowing bonding of different materials on different substrates).

Claims 1, 5, and 7 are rejected under 35 U.S.C. 102(e) as being anticipated by Barmatz et al. (U.S. 6,905,945).

Regarding claims 1 and 5, Barmatz et al. teaches a method comprising:

- depositing a layer of metal on each of a number of conductors disposed on a first wafer (Au 220—further limited by claim 5—deposited on conductor Cr 210 in Fig. 2; column 2, lines 40-46);
- aligning the first wafer (102) with a second wafer (104), the second wafer having a number of conductors disposed on a surface thereof (Fig. 1; column 2, lines 62-64);
- physically contacting the metal layer on each of the conductors of the first wafer with a mating one of the conductors on the second wafer (column 2, line 62 – column 3, line 3); and
- forming a bond between the metal layer on each of the conductors of the first wafer and the mating one conductor of the second wafer, wherein all regions of the first and second wafer surfaces surrounding the mating

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conductors remain unbonded (Figs. 1 and 5; column 2, line 62 – column 3, line 27).

Regarding claim 7, Barmatz et al. teaches the method of claim 1, and further teaches that depositing the layer of metal on each of the conductors of the first wafer comprises forming a blanket layer of the metal over the conductors and the surface of the first wafer; and removing the metal from at least portions of the first wafer surface (column 2, lines 39-46).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 7 and 22 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tong et al. (U.S. 2004/0157407) in view of Wolf et al. (Silicon Processing for the VLSI Era, vol. 1, 1986).

Regarding claims 7 and 22, Tong et al. teaches the methods of claims 1 and 13 (note 35 U.S.C. 102(e) rejection above), but is silent regarding the manner in which the layer of metal on each of the conductors of the first wafer is deposited.

Wolf et al. teaches that it is commonplace to use lift-off techniques to pattern metal layers in silicon processing. Such lift-off techniques comprise forming a blanket layer of the metal on the surface of the conductor and removing portions of the metal layer (pp. 535-536).

Therefore, at the time of the invention, it would have been obvious to one of ordinary skill in the art to use the methods taught by Tong et al., and further use lift-off methods to deposit the layer of metal on each of the conductors of the first wafer, comprising forming a blanket layer of the metal over the conductors and the surface of the first wafer and removing the metal from at least portions of the first wafer surface. The motivation for doing so, at the time of the invention, would have been that Wolf et

al. teaches that this is a common method for patterning metal in semiconductor processing.

Claims 8-11 and 23-26 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tong et al. (U.S. 2004/0157407) in view of Neuhaus et al. (U.S. 2002/0027294).

Regarding claims 8-11 and 23-26, Tong et al. teaches the methods of claims 1 and 13 (note 35 U.S.C. 102(e) rejection above), but does not teach that depositing the layer of metal on each of the conductors of the first wafer comprises selectively depositing the metal on each of the conductors, that selectively depositing the metal comprises an electroless plating process, an electroplating process, or a contact displacement plating process, that the metal layer on each of the conductors of the first wafer comprises a number of islands, or that the islands are selectively deposited on each of the conductors of the first wafer.

Neuhaus et al. teaches a method of performing metal-to-metal bonding for semiconductor wafers comprising electroplating a number of metallic islands (particles) to a metallized contact, which is a mode of selective deposition (paragraphs 0027-0028, 0038, and 0073). Neuhaus et al. teaches that this method eliminates several manufacturing steps, which simplifies the process for component assembly. It also provides improved electrical performance, such as lower metal-to-metal contact resistance (paragraph 0021).

Therefore, at the time of the invention, it would have been obvious to one of ordinary skill in the art to use the methods taught by Tong et al., and use the method

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taught by Neuhaus et al. to electroplate metallic islands onto each of the conductors of the first wafer. The motivation for doing so at the time of the invention would have been to eliminate manufacturing steps and to achieve low metal-to-metal contact resistance, as expressly taught by Neuhaus et al.

Response to Arguments

Applicant's arguments filed 10/10/2006 have been fully considered but they are not persuasive.

Regarding claims 1 and 13, Applicant argues on page 11 that the examiner has misconstrued the teachings of Tong, and that Tong does not disclose the formation of metal-to-metal bonds simply by providing contact between the metal bond pads. While the examiner agrees that Tong's primary teaching is that the chemical bond between wafers provides the pressure necessary to create a *strong* metallic bond between the metal pads, Applicant does not claim a specific method of forming a bond, the strength of the bond, or that the bonded conductors are not easily separable. Therefore, it is still the examiner's position that Fig. 2b illustrates a condition under which a molecular bond, however weak, is formed between the metal pads as they are brought into contact. During patent examination, claims must be given their broadest reasonable interpretation (see MPEP 2111).

However, the examiner finds Applicant's argument that paragraph 0060 of Tong teaches forming a metal-to-metal bond after the wafer surfaces surrounding the metal posts have been bonded persuasive. Since claims 6 and 21 specify a temperature

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range for forming the bond, and Tong does not teach forming the bond within this range, the rejection of claims 6 and 21 made in the Office action dated 8/31/2006 is withdrawn.

Because this action presents new grounds of rejection and indicates allowable subject matter that was previously rejected, this action is made non-final.

Allowable Subject Matter

For reasons indicated in the Office Action dated 6/01/2005, claims 12 and 27 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claims 6 and 21 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Regarding claims 6 and 21, Applicant claims a temperature range of between approximately 100 and 300 degrees Celcius for forming the bond. Although Tong teaches annealing the bond at a temperature within this range, as Applicant points out in the arguments filed 10/10/2006, this annealing step occurs after the wafers themselves are already bonded, so this teaching does not read on claims 6 and 21, since all regions of the first and second wafer surfaces surrounding the mating conductors do not remain unbonded, as required by independent claims 1 and 13, upon which claims 6 and 21 depend. Furthermore, there would be no motivation for one of ordinary skill in the art to combine the teachings of Tong with other relevant art to arrive at forming the bond between a temperature range of 100 to 300 degrees Celcius, since

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Tong specifically teaches forming a method of bonding at room temperature. Furthermore, the process step taught by Tong that the examiner relies on in the rejection of claims 1 and 13 is when Tong forms a bond simply by contacting the two wafers. There would be no reason to raise the temperature above room temperature to perform this step.

Additionally, Barmatz et al. teaches forming a bond in a microwave cavity such that only the metal layers are heated enough to melt and bond. The melting temperature of gold, the metal taught by Barmatz et al., is substantially higher than 300 degrees Celcius. There would therefore be no motivation to perform the bonding step at a temperature within the range claimed by Applicant in claims 6 and 21.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Heather A. Doty, whose telephone number is 571-272-8429. The examiner can normally be reached on M-F, 9:30 - 2:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead, Jr., can be reached at 571-272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For

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CARL WHITEHEAD, JR. SUPERVISORY PATENT EXAMINE

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